



Docket No.: SON-2920
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hironori Ibusuki

Art Unit: 1756

Application No.: 10/780,667

Conf. No. 1986

Filed: February 19, 2004

For: EXPOSURE PATTERN OR MASK AND
INSPECTION METHOD AND
MANUFACTURE METHOD FOR THE SAME

ASSOCIATE POWER OF ATTORNEY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please recognize the following as having Associate Power of Attorney in this case:

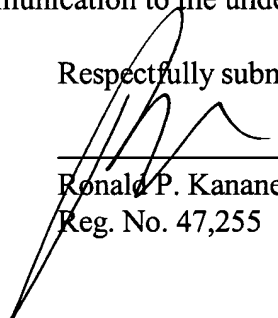
Michael R. Bascobert, Reg. No. 44,525, Brian K. Dutton, Reg. No. 47,255, David T. Nikaido, Reg. No. 22,663, Alexander D. Rabinovich, Reg. No. 37,425, Ralph T. Rader, Reg. No. 28,772, Peter J. Rashid, Reg. No. 39,464, Carl Schaukowich, Reg. No. 29,211, Michael B. Stewart, Reg. No. 36,018, Shawn B. Cage, Reg. No. 51,522, and Lee Cheng, Reg. No. 40,949

of: Rader, Fishman & Grauer PLLC
Suite 501
1233 20th St., NW
Washington, DC 20036

Please continue to direct all communication to the undersigned at the below address.

Respectfully submitted,

Dated: June 18, 2004



Ronald P. Kananen
Reg. No. 47,255

Rader, Fishman & Grauer PLLC
Suite 501
1233 20TH Street, N.W.
Washington, D.C. 20036
Telephone: (202) 955-3750